

Docket No.: HEI-020

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

10/590719

In re Application of

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Confirmation No.

Maki TAKIZAWA et al.

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U.S. Patent Application No.: -----

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Group Art Unit: -----

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Filed: *herewith*

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For: **QUARTZ OSCILLATOR MANUFACTURING METHOD AND QUARTZ
OSCILLATOR**

INFORMATION DISCLOSURE STATEMENT

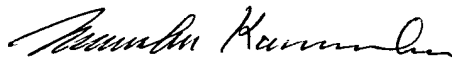
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed with the application and no certification or fee is required.

Respectfully submitted,

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INFORMATION DISCLOSURE CITATION IN AN APPLICATION (PTO-1449)				ATTY. DOCKET NO. HEI-020		U.S. APPLICATION NO. Not yet assigned	
				APPLICANT Maki TAKIZAWA et al		10/590719	
				FILING DATE herewith		GROUP	
U.S. PATENT DOCUMENTS							
EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE	
FOREIGN PATENT DOCUMENTS							
EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
	JP2004-77453	03/11/2004	Japan			abstract	
	JP2002-243451	08/28/2002	Japan			abstract	
	JP2004-93158	03/25/2004	Japan			abstract	
	JP2003-28645	01/29/2003	Japan			abstract	
	JP2004-079869	03/11/2004	Japan			abstract	
	JP2001-196891	07/19/2001	Japan			abstract	
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)							
EXAMINER				DATE CONSIDERED			

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.